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Attorney Docket No. 0756-7709

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )  
Koichiro TANAKA et al. ) Attention: DO/EO/US  
Based On: PCT/JP2005/019456 )  
Filed On: October 18, 2005 )  
For: LASER IRRADIATION METHOD, )  
LASER IRRADIATION APPARATUS )  
AND METHOD FOR )  
MANUFACTURING )  
SEMICONDUCTOR DEVICE )

**PRELIMINARY AMENDMENT**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application before calculation of the government claim fees.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 10 of this paper.